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	Application No.	Applicant(s)	7 60
Notice of Allowability	10/828,336	LEE, TAE-KYOUNG	
	Examiner	Art Unit	•
	Hai C. Pham	2861	
The MAILING DATE of this communication app All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85 NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT I of the Office or upon petition by the applicant. See 37 CFR 1.31	S (OR REMAINS) CLOSED ir 5) or other appropriate commu RIGHTS. This application is s	this application. If not included unication will be mailed in due cours	se. THIS
1. 🖂 This communication is responsive to <u>RCE & Amendment</u>	filed 04/02/07.		•
2. The allowed claim(s) is/are <u>1-25</u> .			
 3.	ve been received.		
3. Copies of the certified copies of the priority d	ocuments have been received	d in this national stage application f	rom the
International Bureau (PCT Rule 17.2(a)).		• .,	
* Certified copies not received:		•	
Applicant has THREE MONTHS FROM THE "MAILING DATE noted below, Failure to timely comply will result in ABANDON THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		a reply complying with the requirer	nents
4. A SUBSTITUTE OATH OR DECLARATION must be subsinFORMAL PATENT APPLICATION (PTO-152) which gi			E OF
5. CORRECTED DRAWINGS (as "replacement sheets") me	ust be submitted.		,
(a) ☐ including changes required by the Notice of Draftspe		(PTO-948) attached	
1) hereto or 2) to Paper No./Mail Date	-	,	
(b) ☐ including changes required by the attached Examine Paper No./Mail Date		in the Office action of	
Identifying indicia such as the application number (see 37 CFR each sheet. Replacement sheet(s) should be labeled as such in			ι) of
6. DEPOSIT OF and/or INFORMATION about the department attached Examiner's comment regarding REQUIREMENT			ihe
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Attachment(s)			
1. Notice of References Cited (PTO-892)	5. Notice of Inf	formal Patent Application	
2. Notice of Draftperson's Patent Drawing Review (PTO-948)		ımmary (PTO-413), Mail Date	
3. Information Disclosure Statements (PTO/SB/08), Paper No./Mail Date		Amendment/Comment	
Examiner's Comment Regarding Requirement for Deposit of Biological Material	8. 🛛 Examiner's	Statement of Reasons for Allowand	æ
or Diological Material	9. Other	•	
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Art Unit: 2861

Request For Continued Examination

1. The request filed on 04/02/07 for a Continued Examination (RCE) under 37 CFR 1.114 based on parent Application No. 10/828,336 is acceptable and a RCE has been established.

Reasons For Allowance

2. The following is an examiner's statement of reasons for allowance: Claims 1-24 are allowed at least for the reason that the prior art of record does not teach or reasonably suggest the structure of the multi-beam light source unit assembly used in a laser scanning apparatus, the light source unit comprising a laser diode unit for discharging a plurality of laser beams, a rotational member for supporting the diode unit and rotating to a substantially aligned position between a plurality of the laser beams, a fixing member for supporting the rotational member in a rotatable manner, a temporary joining part for maintaining joining status between the rotational member and the fixing member such that the rotational member rotates under elastic force, wherein the elastic force is increased when the rotational member is rotated for position alignment between the plurality of the laser beams, and a fixing part for fixing the rotated rotational member to the fixing member, as set forth in the claimed combination.

Claim 25 is allowed at least for the reason that the prior art of record does not teach or reasonably suggest the multi-beam light source unit comprising a laser diode unit for discharging a plurality of laser beams, a rotational member for supporting the

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diode unit, said rotational member having a boss, and a fixing member for supporting the rotational member in a rotatable manner, wherein said fixing member includes a boss cavity and a plurality of elastic ribs on an inner periphery of the boss cavity for elastically supporting the outer periphery of the boss at a plurality of positions, as set forth in the claimed combination.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Contact Information

3. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Hai C. Pham whose telephone number is (571) 272-2260. The examiner can normally be reached on M-F 8:30AM - 5:30PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Matthew Luu can be reached on (571) 272-7663. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a

USPTO Customer Service Representative or access to the automated information

system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

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HAI PHAM PRIMARY EXAMINER

Hareli Phan

June 27, 2007